

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 20, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG644400357

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.54 - 6.57 X 4.01 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.07 CARAT

D

VVS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

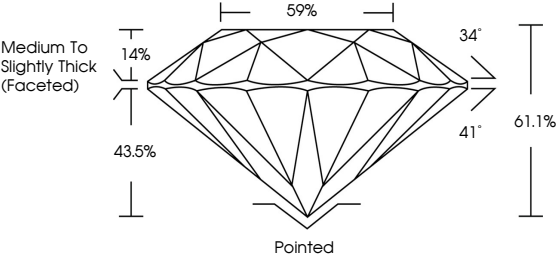
EXCELLENT

NONE

 LG644400357

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

59%

34°

41°

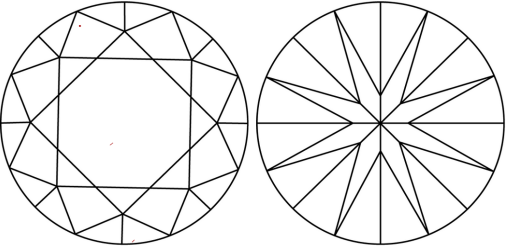
61.1%

43.5%

14%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



July 20, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG644400357

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.54 - 6.57 X 4.01 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.07 CARAT

D

VVS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

 LG644400357

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



IGI

July 20, 2024

IGI Report No LG644400357

ROUND BRILLIANT

6.54 - 6.57 X 4.01 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.07 CARAT

D

VVS 2

IDEAL

61.1%

59%

EXCELLENT

EXCELLENT

NONE

 LG644400357

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa